

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Michaial Duff Howell et al.

Application No.: 10/625,407

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For: METHOD AND APPARATUS FOR PREPARING SEMICONDUCTOR WAFERS FOR MEASUREMENT

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CHANGE OF ATTORNEY OR AGENT'S ADDRESS IN APPLICATION (37 CFR 1.8(a))

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M/S AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 **CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope, addressed to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450 on August 2, 2004

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